



PATENT
2185-0578P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Yoshinobu ONO et al. Conf.: 3053

Appl. No.: 09/977,375 Group: 2811

Filed: October 16, 2001 Examiner: Junghwa I

For: 3-5 GROUP COMPOUND SEMICONDUCTOR AND
LIGHT-EMITTING ELEMENT

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LARGE ENTITY TRANSMITTAL FORM

Assistant Commissioner for Patents
Washington, DC 20231

June 20, 2002

Sir:

Transmitted herewith is a Reply to Restriction/Election Requirement in the above-identified application.

- ☐ The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.
- ☐ Petition for _____ () month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time.
- ☒ No fee is required.
- ☐ A check in the amount of \$0.00 is enclosed.
- ☐ Please charge Deposit Account No. 02-2448 in the amount of \$0.00. A triplicate copy of this sheet is attached.

Appl. No. 09/977,375

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

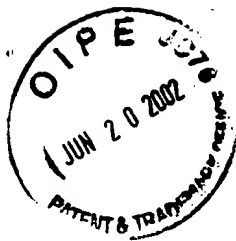
By 

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REPLY TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents
Washington, DC 20231

June 20, 2002

Sir:

In reply to the Restriction Requirement dated May 21, 2002, the following remarks are respectfully submitted in connection with the above-identified application.

REMARKS

Claims 1-13 are pending in the present application.

The Examiner has required election in the present application between:

Group I, claims 1-11, drawn to a semiconductor device; and
Group II, claims 12-13, drawn to a method of measuring dislocation density.

For the purpose of examination of the present application, Applicants elect, without traverse, Group I, claims 1-11.